

Application No.  
10/707,905

Group	2811
-------	------

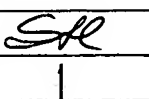
## U.S. PATENT DOCUMENTS

[illegible]

## FOREIGN PATENT DOCUMENTS

[illegible]

**OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)**

	1	English Language Abstract of JP 4-062977.
	2	English Language Abstract of JP 2003-318414.
	3	English Language Abstract of JP 1-019779.
	4	An Article of VELLANKI et al., entitled: "Highly Conductive n+ Layers in InP:Fe Created by MeV Energy Si, S, and Si/S Implantation for Application to Microwave Devices", Journal of Electronic Materials, Vol. 22, No. 1, 1993, pp. 03-10.

DATE CONSIDERED 6/23/05

\*EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

Best Available Copy